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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO	
10/623,679	07/22/2003	Koji Nozaki	030891	5083	
38834	34 7590 08/03/2004		EXAMINER		
WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP 1250 CONNECTICUT AVENUE, NW			WALKE, AMANDA C		
SUITE 700		ART UNIT	PAPER NUMBER		
WASHINGTO	ON, DC 20036	1752			
				DATE MAIL ED: 08/03/2004	

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)				
Office Action Summary	10/623,679	NOZAKI ET AL.				
Office Action Summary	Examiner	Art Unit				
	Amanda C Walke	1752				
The MAILING DATE of this communication appears on the cover sheet with the correspondence address Period for Reply						
A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely. - If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication. - Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).						
Status						
1) Responsive to communication(s) filed on 22 July 2003.						
2a) This action is FINAL . 2b) This action is non-final.						
3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.						
Disposition of Claims						
4) Claim(s) 1-28 is/are pending in the application. 4a) Of the above claim(s) is/are withdrawn from consideration. 5) Claim(s) is/are allowed. 6) Claim(s) 1-28 is/are rejected. 7) Claim(s) is/are objected to. 8) Claim(s) are subject to restriction and/or election requirement.						
Application Papers						
9) The specification is objected to by the Examiner 10) The drawing(s) filed on 22 July 2003 is/are: a) Applicant may not request that any objection to the d Replacement drawing sheet(s) including the correction 11) The oath or declaration is objected to by the Examiner	accepted or b) objected to b frawing(s) be held in abeyance. See on is required if the drawing(s) is obj	37 CFR 1.85(a). ected to. See 37 CFR 1.121(d).				
Priority under 35 U.S.C. § 119						
12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some * c) None of: 1. Certified copies of the priority documents have been received. 2. Certified copies of the priority documents have been received in Application No 3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received.						
Attachment(s)						
1) Notice of References Cited (PTO-892)	4) Interview Summary (PTO-413)				
 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) Paper No(s)/Mail Date 11/19/03,2/19/04. 	Paper No(s)/Mail Dai 5)					

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DETAILED ACTION

Specification

1. The lengthy specification has not been checked to the extent necessary to determine the presence of all possible minor errors. Applicant's cooperation is requested in correcting any errors of which applicant may become aware in the specification.

Claim Rejections - 35 USC § 103

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- 2. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 3. Claims 1-8, and 14-28 are rejected under 35 U.S.C. 103(a) as being unpatentable over Yasuda et al (JP 2001-033984 in view of its English language translation).

Yasuda et al disclose a negative resist material to be coated onto a substrate, exposed, then developed to form a pattern. The resist comprises a resin (novolac, polyvinyl ether, polyvinyl acetal, etc.) meeting the instant claim limitations, a crosslinking agent (preferably melamine), an organic solvent meeting the instant claim limitations, and optionally a surfactant ([0036], [0048]). The solvent may be anionic, cationic, nonionic, amphoteric, ethyleneoxide, fatty acid amides, fatty acid esters, quarternary ammonium salts, and/ or betaine. The process of forming a pattern includes employing a photomask and developing the resist optionally with pure water ([0037], [0041], [0086]).

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Given the teachings of the reference, it would have been obvious to one of ordinary skill in the art to prepare the material of Yasuda et al choosing to add any of the disclosed surfactants with reasonable expectation of achieving a material able to form an accurate fine pattern.

4. Claims 9-13 are rejected under 35 U.S.C. 103(a) as being unpatentable over Yasuda et al in view of Sato et al (5,955,241).

Yasuda et al has been discussed above, but fails to teach or suggest the addition of a water soluble aromatic compound.

Sato et al disclose a chemical-amplification-type negative resist composition and a method for forming a negative resist pattern using the same. The chemical-amplification-type negative resist composition comprises an alkali-soluble resin, an acid-generating agent, and a compound capable of causing crosslinking reaction in the presence of an acid.

The reference further teaches "Additionally, the chemical-amplification-type negative resist composition of the present invention may further contain a light-absorbing ingredient. Examples of compounds which can be used as the light-absorbing ingredient include naphthoquinone-1,2-diazide-5-sulfonic esters of polyphenols such as 1-[1-(4-hydroxyphenyl)isopropyl]-4-[1,1-bis(4-hydroxyphenyl)ethyl]benzene and bis(4-hydroxy-3,5-dimethylphenyl)-3,4-dihydroxyphenylmethane; benzophenone; 2,2',4,4'-tetrahydroxybenzophenone; 2,3,3',4,4',5'-hexahydroxybenzophenone; 4-dimethylamino-2',4'-dihydroxybenzophenone; 5-amino-3-methyl-1-phenyl-4-(4-hydroxyphenylazo)pyrazole; 4-dimethylamino-4'-hydroxyazobenzene; 4-diethylamino-4'-ethoxyazobenzene; 4-diethylaminoazobenzene; and curcumine.

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The addition of such a light-absorbing ingredient is effective in improvement of sensitivity and definition, and the resulting resist pattern does not exhibit a wavy sectional shape but exhibits a suitable rectangular sectional shape. "

Given the teachings of Sato et al, it would have been obvious to one of ordinary skill in the art to prepare the material of Yasuda et al choosing to add a light absorbing compound of Sato et al to achieve an increase in the sensitivity of the material, with reasonable expectation of achieving a material able to form an accurate fine pattern.

Conclusion

5. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. Kunita et al (6,214,518 and 6,083,658), Aoshima et al (6,403,283), Van Damme et al (6,300,032), and Sakurai et al (6,368,774) are cited for their teachings of similar materials.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Amanda C Walke whose telephone number is 571-272-1337. The examiner can normally be reached on M-R 5:30-4.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Mark Huff can be reached on 571-272-1385. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Amanda C Walke Examiner Art Unit 1752

ACW July 25, 2004